

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of: )  
 )  
Jan, Chia-Hong, et al. )  
 )  
U.S. Serial No: 09/477,764 ) Examiner: Vu, Hung K.  
 )  
Filed: January 4, 2000 ) Art Unit: 2811  
 )  
For: A DEVICE HAVING RECESSED )  
SPACERS FOR IMPROVED SALICIDE )  
RESISTANCE ON POLYSILICON GATES )

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT AND REQUEST FOR CONTINUED  
EXAMINATION UNDER 37 C.F.R. § 1.114**

Dear Sir:

This is in response to the Final Office Action mailed on August 7, 2006 and a Request for Continued Examination (R.C.E.) under 37 C.F.R. § 1.114 filed concurrently herewith. Applicants respectfully request the Examiner to enter this Preliminary Amendment and consider the following remarks.